



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of

Nathan S. Lewis *et al.*

Application No.: 09/905,157

Filed: July 12, 2001

For: ELECTRICAL PASSIVATION OF
SILICON-CONTAINING SURFACES
USING ORGANIC LAYERS

) **Mail Stop Amendment**

) Group Art Unit: 2813

) Examiner: Heather Anne Doty

) Confirmation No.: 2732

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RESPONSE

Commissioner for Patents
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Sir:

The following remarks are in response to the Office Action mailed April 17,
2006. Please enter the following remarks: